



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:) **CONFIRMATION NO.: 2876**
)
) **Shingo HISHIYA**
)
U.S. Serial No.: 10/554,086) **Group Art Unit: 1792**
)
Filed: October 21, 2005) **Examiner: Rudy Zervigon**

For: **METHOD AND APPARATUS FOR MODIFYING SURFACE OF INTERLAYER
INSULATING FILM**

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir :

A response to the Office Action mailed June 26, 2008 is due by July 26, 2008. The Action required restriction between two patentably distinct inventions.

Applicant hereby elects Group I of claims 1-8, drawn to a method for modifying a surface, for examination in this application.

Applicant reserves the right to file divisional application(s) for the non-elected claims in due course.

It is submitted that this application now is in condition for examination on the merits and early action in that regard is solicited.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

A handwritten signature in black ink, appearing to read "Michael A. Makuch", written over a horizontal line.

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